

# Erratum to “Nonlinear Dissipation in Epitaxial SCS and Polysilicon MEMS Driven at Large Amplitudes”

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In the above article [1], two authors, Christopher P. Cameron and Gabrielle D. Vukasin, were mistakenly omitted from the byline. The correct byline should read:

Anne L. Alter, Ian B. Flader, Christopher P. Cameron, Gabrielle D. Vukasin, Yunhan Chen, Dongsuk D. Shin, and Thomas W. Kenny.

The correct footnote information should read:

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## REFERENCES

- [1] A. L. Alter, I. B. Flader, Y. Chen, D. D. Shin, and T. W. Kenny, “Nonlinear dissipation in epitaxial SCS and polysilicon MEMS driven at large amplitudes,” *J. Microelectromech. Syst.*, vol. 29, no. 5, pp. 1118–1120, Oct. 2020.

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